

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



In re Application of:)	
	:	Examiner: Not Assigned
SHINICHI HARA, ET AL.)	
	:	Group Art Unit: 2851
Application No.: 09/818,625)	
	:	
Filed: March 28, 2001)	
	:	
For: EXPOSURE APPARATUS, GAS)	June 28, 2001
REPLACEMENT METHOD,	:	
SEMICONDUCTOR DEVICE)	
MANUFACTURING METHOD,	:	
SEMICONDUCTOR MANUFACTURING)	:	
FACTORY, AND EXPOSURE	:	
APPARATUS MAINTENANCE)	
METHOD	:	

Box Missing Parts
The Commissioner for Patents
Washington, D.C. 20231

REQUEST FOR CORRECTED FILING RECEIPT

Sir:

Applicants' attorneys have received an official Filing Receipt in the above-identified application in which the following has changed:


The Address of the Fourth Inventor, Toru HIRABAYASHI has changed from "Tokyo, Japan" to --Tochigi, Japan--.

Applicants request issuance of a corrected Filing Receipt, corrected as shown above, is accordingly respectfully requested.

The Commissioner is authorized to charge Deposit Account No. 06-1205 should any fees be deemed necessary for this correction. A duplicate of this paper is enclosed for this purpose.

Applicants' undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our address given below.

Respectfully submitted,



Attorney for Applicants

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